



**PATENT**  
Attorney Docket No. NEX-006C  
(formerly ASX-054C)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

#8  
12-24-02  
Payton

APPLICANT(S): Klein et al.  
SERIAL NO.: 09/917,224 GROUP NO.: 2823  
FILING DATE: July 27, 2001 EXAMINER: K. D. Nguyen  
TITLE: Substrate Processing Pallet and Related Substrate Processing Method and Machine

Box Non-Fee Amendment  
Commissioner for Patents  
Washington, D.C. 20231

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**RESPONSE**

Sir:

In response to the Office action mailed from the U.S. Patent Office on September 11, 2002, Applicants submit this Response. Applicants believe that no fees are due, but the Commissioner is hereby authorized to charge any required fees to Deposit Account No. 20-0531.

**REMARKS**

Claims 1-17, as filed, remain pending in the application.

**Priority Under 35 U.S.C. § 119**

Applicants request that the Examiner acknowledge the claim for domestic priority under 35 U.S.C. 119(e) to provisional application Serial No. 60/221,030, filed July 27, 2000.

**Rejection of Claims 1-9 Under 35 U.S.C. § 102(e)**

Claims 1-9 are rejected under 35 U.S.C. § 102(e) as being anticipated by U.S. Patent No. 6,217,272 to Felsenthal (“Felsenthal”). Applicants respectfully submit, however, that Felsenthal does not anticipate claim 1 because Felsenthal does not teach all of the limitations recited by claim 1. This conclusion is supported by the following reasons.

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